

Title (en)  
ASSEMBLY AND METHOD FOR THE OPTICAL-TACTILE MEASUREMENT OF A STRUCTURE

Title (de)  
ANORDNUNG UND VERFAHREN ZUM OPTO-TAKTILEN MESSEN VON STRUKTUREN

Title (fr)  
DISPOSITIF ET PROCEDE DE MESURE OPTO-TACTILE DE STRUCTURES

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Application  
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Abstract (en)  
[origin: WO0225206A1] The invention relates to an assembly for the optical-tactile measurement of the structure of an object (12), using a co-ordinate measuring device (10). Said device comprises a contact stylus (18) with a stylus extension that is elastic at least at its end, said extension ending in a stylus element that probes the object. To measure the structure of an object (12) with a high degree of precision and the required coverage, the optical sensor and the contact stylus are integrated into one unit or form a single entity.

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